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Electrification of fertilizer production *via* plasma-based nitrogen fixation: a tutorial on fundamentals

Mikhail Gromov,^{id}*^{ab} Yury Gorbanev,^{id}^{cd} Elise Vervloessem,^{id}^c Rino Morent,^a Rony Snyders,^{ef} Nathalie De Geyter,^{id}^a Annemie Bogaerts^{id}^{cd} and Anton Nikiforov^a

Nitrogen-containing fertilizers are key chemicals for our population, ensuring the constantly growing demands in food production. Fertilizers promote vegetative growth, specifically through the formation of amino acids, the building blocks of proteins. However, the current synthesis method relies on the Haber–Bosch process for ammonia synthesis, one of the largest-volume chemicals made globally, having a significant environmental impact. The need for a sustainable and green industry with low CO₂ emission triggers the demand to reconsider the current fertilizer production approach. In this context, electrified, local, small-scale production emerges as a promising option to address current environmental and economic challenges. This approach allows production to be consumer-oriented while adhering to environmental regulations. In light of this, non-equilibrium plasma technology has gained a wave of attention. Plasma-based nitrogen fixation has a long history, starting more than a century ago. It was one of the first nitrogen fixation methods invented and later replaced by more energy-efficient technologies. In the current paradigm, this approach can fulfill all industrial and social demands: it perfectly aligns with non-stable renewable energy, is carbon-neutral, relatively simple to maintain, and can provide a valuable source of fixed nitrogen on a small-scale, on-farm production with complete control over land processing. The plethora of existing publications on plasma-based nitrogen fixation addresses the concept of synthesizing nitrogen-containing fertilizers. However, despite significant advancements in the field and the availability of numerous reviews, they tend to focus on specific aspects, such as plasma physics (e.g., the role of vibration excitation), plasma-initiated chemistry (e.g., nitrogen oxidation or reduction), or reactor design. This tutorial review aims to bridge these gaps by presenting an integrated and accessible explanation of the interconnections between different aspects affecting plasma-based nitrogen fixation. It is designed both for newcomers to the field and those who want to broaden their knowledge, highlighting the current state-of-the-art and offering insights into future research directions and implementations.

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Sustainability spotlight

Plasma technology presents an attractive alternative for converting N₂ into nitrogen-based fertilizers in a manner that aligns with current sustainability goals. However, this necessitates a reconsideration of the existing soil fertilization paradigm: a pivot from large-scale centralized production to on-site direct synthesis. Although challenging, this can bring immense collective benefits. In this approach, valuable nitrogen species (NO₃[−] and/or NH₄⁺) do not require separation or recycling, thereby reducing associated energy costs. Instead, they can be synthesized directly from inexpensive feedstock (air) using plasma oxidation or reduction processes, and applied shortly thereafter. Our work emphasizes the importance of the following UN sustainable development goals: zero hunger (SDG 2); industry, innovation and infrastructure (SDG 9), climate action (SDG 13).

1 Introduction

The challenge of sustainable nitrogen fixation has garnered increasing attention in the context of mitigating climate change and achieving global food security. Plasma-based nitrogen fixation (NF), leveraging non-thermal plasma technologies, offers a promising alternative to conventional processes like the Haber–Bosch process. Plasma NF has the potential to decentralize fertilizer production, reduce greenhouse gas emissions, and utilize renewable energy sources.

^aResearch Unit Plasma Technology (RUPT), Department of Applied Physics, Ghent University, 9000 Ghent, Belgium. E-mail: mikhail.gromov@ugent.be

^bLeibniz Institute for Plasma Science and Technology (INP), 17489 Greifswald, Germany

^cResearch Group PLASMANT, Department of Chemistry, University of Antwerp, 2610 Wilrijk, Belgium

^dElectrification Institute, University of Antwerp, 2020 Antwerp, Belgium

^eChimie des Interactions Plasma-Surface (CHIPS), CIRMAP, University of Mons, 7000 Mons, Belgium

^fMateria Nova Research Centre, Parc Initialis, 7000 Mons, Belgium



This tutorial is designed to serve as a learning resource for those who are new to the field of plasma-based nitrogen fixation or wish to broaden their understanding of its fundamentals. It aims to provide a comprehensive overview of the key process aspects, including the basics of plasma phenomena and plasma-initiated chemistry in different feedstock atmospheres, and, more importantly, to illustrate the interconnections between various process parameters. By synthesizing knowledge from various plasma-related disciplines with state-of-the-art examples, this review seeks to create a cohesive narrative explaining how plasma technologies can contribute to the nitrogen fixation and fertilizers industry.

The primary audience for this review includes:

- Graduate students and early-career researchers entering the field of plasma-based technologies or green chemistry.
- Industry professionals and engineers exploring sustainable nitrogen fixation alternatives for local or small-scale applications.
- Policymakers and educators interested in understanding the potential of plasma-based systems for environmental and economic benefits.

Structure of the tutorial.

To achieve its objectives, the tutorial is organized into the following sections:

- (1) Nitrogen fixation and electrification of the chemical industry: a brief overview of nitrogen fixation methods, from the Haber–Bosch process to modern plasma-based approaches.
- (2) Fundamentals of plasma and plasma-based nitrogen fixation: this section explains the basics of plasma-initiated kinetics, the generation of reactive species, and the vibrational ladder-climbing phenomenon that makes non-thermal plasma so chemically attractive.
- (3) Plasma nitrogen fixation: chemistry: an overview of the state-of-the-art N_2 oxidation and N_2 reduction processes, focusing on underlying chemical mechanisms in different plasma systems.
- (4) From plasma nitrogen fixation to NH_4NO_3 fertilizer: based on insights into nitrogen fixation fundamentals, this section proposes and discusses a conceptual process to convert atmospheric N_2 into ready-to-use fertilizer.
- (5) Conclusion and outlook: a summary of progress in plasma-based nitrogen fixation to date, with possible future research directions outlined.

Through this structured approach, the review aims to bridge existing knowledge gaps and inspire further innovation in plasma-based nitrogen fixation.

2 Nitrogen fixation and electrification of the chemical industry

2.1 Nitrogen fixation in nature

Nitrogen (N), phosphorus (P), and potassium (K) are essential elements for plant growth and the foundation of modern soil fertilization. Nitrogen, a vital component of all living organisms, forms the structural basis of life.¹ For plants, it supports chlorophyll formation, which is crucial for photosynthesis, and

plays a key role in amino acid and protein synthesis. Nitrogen deficiency slows growth and destroys chlorophyll, while excess weakens plants' resistance to diseases. Phosphorus drives energy storage, photosynthesis, and respiration, while potassium regulates water balance, strengthens cell walls, and enhances stress resistance. Together, phosphorus and potassium stimulate the synthesis of nitrogen-based biopolymers and improve water retention, optimizing resource use. These elements collectively ensure energy balance, cellular stability, and plant productivity, boosting resilience to adverse conditions. Therefore, nitrogen, phosphorus, and potassium are all equally important for efficient crop growth.² Potassium is mined as potassium chloride, and phosphate is derived from phosphate rock, both of which undergo refinement and manufacturing. In contrast, nitrogen, comprising about 78% of the atmosphere, is converted into fertilizer through fixation *via* reduction or oxidation.

The only source of N for plants is from molecular nitrogen in air that is first required to be activated through:

- N_2 oxidation into $(H)NO_x$
- N_2 reduction into NH_3 .³

To some extent, this process of nitrogen fixation (NF) occurs in nature *via* abiotic (lightning) and biotic processes (fixation by aquatic and non-aquatic microorganisms), thus providing the basis for the growth of crops as a food source.^{4–6}

2.2 The current landscape of artificial nitrogen fixation

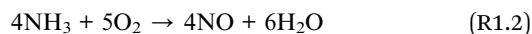
The increasing food demands due to the ever-growing human population require more fixed N_2 than nature supplies. For this reason, the soil has to be supplemented with additional nitrogen, originating initially from natural sources (*e.g.*, organic waste or planting N_2 fixing legumes⁷) and further from synthetic fertilizers.³ Currently, synthetic fertilizers used to grow crops as a direct feedstock, as well as food for sustaining livestock, are estimated to sustain half of the planet's population.⁷

The thermo-catalytic Haber–Bosch (HB) process for nitrogen fixation into ammonia (NH_3), commercialized in 1913, is one of the main industrial chemical processes that has been frequently described as the major reason for the rapidly growing human population during the last century.^{8,9} NH_3 is synthesized from N_2 and H_2 gases (R1.1) in the presence of a catalyst (Fe, Ru). Natural gas is typically used as the H_2 source for NH_3 and as the source of energy to create the high pressure (200–300 atm) and temperature (>700 K) required for the synthesis. In the next step, the produced gas is cooled down, compressed, and condensed, yielding liquid NH_3 as the final product.¹⁰ Although the diverse NH_3 applications span from textile and plastics production to pharmaceuticals and automotive industry, up to 80% of the globally produced NH_3 *via* the HB process is used for the production of fertilizers.³

NH_3 itself is not a direct agricultural fertilizer but serves as a vital component in the production of various fertilizers, including ammonium salts. Ammonium nitrate (NH_4NO_3) stands out as the most widely used. Nitric acid (HNO_3), also necessary to synthesize NH_4NO_3 , ranks among the world's 15 largest commodity chemicals.¹¹ It is manufactured through the



Ostwald process, which involves the catalytic oxidation of NH_3 , prepared *via* the HB process, and further steps involving NO_x , as summarized in global reactions (R1.2)–(R1.6).¹²



Therefore, the production of HNO_3 is directly limited by NH_3 synthesis through the HB process.

2.3 Drivers of change in the nitrogen fixation industry

In the current stage, almost 50% of food production and consumption depends on a single chemical process, which is HB. The tremendous production volume triggers many harmful consequences. The process requires nearly 2% of the total energy produced worldwide, 3–5% of the globally extracted natural gas, and emits >400 Mt of CO_2 annually¹³ – more than a quarter of the total chemical industry emissions.^{4,14,15} Although modern HB plants convert part of the CO_2 (150 Mt per year) into urea ammonium nitrate (UAN), which is also used as fertilizer, this still cannot offset the carbon emission.¹⁶ Other strategies to reduce CO_2 emissions include full or partial process electrification, such as decarbonizing the hydrogen source (produced electrolytically from water) and utilizing renewable energy to power the HB process.¹⁶ However, it's worth noting that the energy cost of NH_3 produced in such electrified HB processes is almost 1.5 times higher than that of traditional fossil fuel-based processes.^{16–18} Nevertheless, despite the rise of

renewable energy, current HB plants, due to their high inertia, cannot accommodate the intermittency of fluctuating energy sources, such as wind and solar.¹⁹

Because of the highly energy-intensive conditions required for the HB process operation and its heavy reliance on CH_4 , HB becomes economically feasible only on large industrial scales in regions with established natural gas supplies.²⁰ This results in massive centralized production, subsequent costly distribution of the produced NH_3 , as shown in Fig. 1a, and a large dependency on price volatility in the energy market. Furthermore, the distribution of NH_4NO_3 produced *via* the combined HB-Ostwald process is often done in the most economically feasible form, *i.e.*, as a dry solid salt, whose explosive properties resulted in multiple lethal accidents during transportation and storage in the last decade alone.²¹ The recent geopolitical events also showed that an unstable supply of CH_4 (to be used for fertilizers production in a specific region) and the ready-made fertilizers delivery (into a country) create an unsustainable network with unpredictable performance.^{22–24} Nonetheless, it has to be acknowledged that due to the extremely extensive optimization of HB for over a century of its existence, the energy cost (EC) of the HB-produced NH_3 is a meager 0.48 MJ mol^{-1} (0.70 MJ mol^{-1} for electrified HB), which corresponds to a theoretical minimum obtainable with the employed pathway of NF.^{16,17,25}

Finally, one more important point motivating the change in the paradigm of the current NF industry is that, at present, more than 50% of the applied N in the form of fertilizer is lost to the atmosphere and water streams,^{19,26} damaging aquatic organisms and causing air pollution.^{27,28}

2.4 Nitrogen fixation *via* electrified plasma technology

To this extent, we can summarize that a future alternative should be independent of rare resources and has to be carbon-neutral to address the current ecological crisis. In line with this goal, significant efforts are directed toward developing alternatives to industrial-scale NF due to its associated challenges,



Fig. 1 Schematic representation of the fertilizer production and delivery chain for HB-based (a) and plasma-based (b) NH_4NO_3 . The plasma-based route used as an example here involves electrocatalytic reduction as one step to directly obtain an aqueous solution of NH_4NO_3 .



which are expected to worsen with increasing demand. These alternatives include complementary NF processes, such as enzyme-based, plasma-based, and (electro-)catalytic methods using both heterogeneous and homogeneous catalysts.^{5,29–32} Among these technologies, the plasma-based NF approach stands out due to the following advantages, which are also schematically depicted in Fig. 1b:

- Plasma or electrical discharge allows the direct conversion of electrical energy into gas-phase chemical products.
- Plasma is a plug-and-play technology, making it fully compatible with renewable energy sources that fluctuate over time.^{17,33,34}
- Theoretical estimations suggest plasma NF can be less energy-intensive than the HB process: the minimum theoretical energy cost of plasma-based NF is estimated at only 0.2 MJ mol⁻¹ (discussed in detail in the following sections).³⁵
- Plasma enables on-site fertilizer production, potentially reducing nutrient loss and ammonia pollution by up to 25%.³⁶

Therefore, plasma technology can provide a sustainable and eco-friendly small-scale process that is compatible with renewable energy sources, completely fossil fuel-free, and carbon-free. It fulfils requirements for producing fertilizers directly on-site where they will be used and in amounts they are needed. It is important to note that this approach does not seek to completely copy the performance metrics of HB (*e.g.*, to reach its EC values). Instead, a completely decentralized alternative, which eliminates all need for distribution, is very sought-after.

Nowadays, two of the most used N-containing fertilizers are urea (CO(NH₂)₂) and ammonium nitrate (NH₄NO₃) because of their high nitrogen content (46 and 34% by weight, respectively), cost-effectiveness, and high solubility in water. The major differences between them, from application point of view, are related to their handling, characteristics, and timing of nitrogen release. NH₄NO₃ requires more attention for storage and transport due to its hygroscopic properties, *i.e.*, the ability to absorb atmospheric moisture. Nitrogen release to plants undergoes hydrolysis, and in the case of CO(NH₂)₂, it converts to ammonium (NH₄⁺) and bicarbonate ions, while NH₄NO₃ provides nitrogen in two forms of NH₄⁺ and NO₃⁻. This affects the timing of their application due to the different uptake mechanisms of NO₃⁻ and NH₄⁺ ions by plants. CO(NH₂)₂ is applied during rain or irrigation to assist the movement of nitrogen into the soil. NH₄⁺ is retained in the soil, but nitrogen losses can occur due to NH₃ gas volatilization. However, NH₄NO₃ can be applied at any time. NO₃⁻ is readily available to plants, and NH₄⁺ is retained in the soil and slowly consumed.

The most effort has been made in the plasma community towards either nitrates or ammonia production, whereas urea (and UAN) is much less addressed. One of the reasons is that the biological cycle of urea results in CO₂ emission, which makes it environmentally a lot less attractive and compromises the global challenge of reducing CO₂ emissions from the agricultural sector. This brings us to the concept of plasma-based NF into NO_x and NH₃, and ultimately into a fertilizer – NH₄NO₃.

The plasma-based NF approach has yielded numerous publications and reviews with various degrees of detailization.^{29,37–43} However, an easily accessible, up-to-date

overview of plasma-based NF processes towards fertilizers, which could serve as a tutorial, has not been available so far. Therefore, this work aims to fill this knowledge gap, especially for those who are new in the field, underlying what is already well-understood and established, as well as guiding towards new, promising research directions.

3 Fundamentals of plasma and plasma-based nitrogen fixation

This section provides an overview of plasma's key metrics and explores the unique characteristics that make plasma a powerful driver of non-conventional chemistry. The section begins with the definition of plasma and the fundamental principles behind plasma generation. The discussion then moves to the classification of different plasma types, emphasizing their distinct properties. Key elementary processes that underpin plasma chemistry are introduced, followed by an analysis of its advantages and limitations in industrial and scientific applications. This foundation sets the stage for understanding plasma's role in NF.

3.1 Basics of electrical discharges known as plasma

Irving Langmuir first introduced the term plasma in his article published in the Proceedings of the National Academy of Sciences in 1928.⁴⁴ Plasma is a quasi-neutral, ionized gas consisting of electrons, ions, photons, and neutrals in the ground and excited states. Plasma is referred to as the fourth state of matter due to its abundant presence in nature (>99% of the visible universe is plasma). In laboratory conditions, plasma can be generated in any gas by different means of providing energy to ionize the gas, including (i) heating the gas, (ii) applying a strong electrical field, (iii) focusing laser or microwave (MW) radiation, and some others. Depending on the energy of the electrons and heavy particles, plasmas can be divided into two large classes:

- Plasmas at local thermodynamic (or thermal) equilibrium (LTE);
- Plasmas at non-local thermodynamic equilibrium (non-LTE).⁴⁵

LTE, or thermal plasmas, are characterized by an established equilibrium between every collision balanced by its inverse process, *i.e.*, excitation/de-excitation, ionization/recombination. In this case, the temperature of heavy particles or gas temperature (T_g) is equivalent to the temperature of the electrons (T_e). Here and later in the paper, the Maxwellian distribution of particle energy is expected to hold for both electrons and heavy species, so the macroscopic parameter, temperature, can be used to describe the energy of the species. In the more general case, the electron energy distribution function (EEDF) has to be used instead of T_e , and deviation from the Maxwellian distribution can be considerable, especially in low pressure plasmas.⁴⁶

In turn, de-excitation processes in non-LTE, or non-thermal, plasmas are characterized by different energy distributions between energetic electrons and heavy particles, and typically,



T_e is much higher than T_g and the ion temperature (T_{ions}). Both thermal and non-thermal plasmas can be generated at low and atmospheric pressure, whereas high pressure operation often results in fast thermalization of the discharge due to a high number of collisions between particles. Plasma operation at low pressure provides a convenient way to control the energy of electrons, as the latter can only participate in a few collisions with other species and can gather substantial energy. Such plasmas can be very uniform and reach complete ionization, *i.e.*, fusion plasmas in tokamaks, but they are not adapted for NF on an industrial scale due to the requirement of vacuum equipment. Thus, in this overview, the primary focus lies on atmospheric (or high) pressure plasmas as the only feasible way to implement plasmas for NF.

3.2 Elementary processes in plasmas

At high pressure (~ 1 atm), electrons are the first to receive energy from the electric field and distribute it among the other plasma components. The energy transfer from an externally supplied electrical field to electrons and consequently to other species (ions, metastables, radicals, *etc.*) provides a possibility to create a mixture rich in reactive species and so initiate unique chemistry with the use of electrical energy. As such, plasmas of high pressure are often considered a sort of plasma-chemical reactor where unique chemical reactions take place. The main elementary processes initiated in plasma, important for gas conversion chemistry, are schematically presented in Table 1.

The main electron-initiated processes are P1–P6. These processes are generally divided into two groups, representing elastic and inelastic collisions. The first group, described as P1, changes the kinetic energy of the neutral species. At high pressure, due to the high frequency of collisions, the P1 process is attributed to gas heating. The second group, P2–7, is a set of processes determining plasma's unique properties, creating a manifold of highly reactive species and so capable of initiating plasma chemical reactions. These inelastic collisions between electrons and heavy particles can dissociate molecules (P2),

modify the electronic structure of the neutral species, *i.e.*, excite (P3, electronically (E) and/or vibrationally (ν)) or ionize (P4) them, and can lead to electron attachment/detachment (P5–P6). Electron collisions with heavy particles, which lead to the formation of excited species, have a particular interest in gas conversion (P3.1–P3.4). This is because these formed species can also have enough energy to overcome a reaction's activation energy barrier (E_a) and participate in gas conversion, particularly in NF. Electrons can transfer their energy to other species, resulting in the formation of ions (P4, *e.g.*, N_2^+), electronically excited (P3.1, *e.g.*, $N_2(A, B, C)$), and vibrationally excited species (P3.2, *e.g.*, $N_2(\nu_x)$). These energetic particles will also transfer their energy in processes such as P2.1 and P4.1, significantly contributing to gas conversion. However, the same energetic species can also exchange (more often lose) their energy in vibrational–vibrational (V–V, P3.3) and vibrational–translational (V–T, P3.4) energy exchange reactions, through which vibrational energy is converted to heat. Finally, electronically excited species can lose their energy by radiation (P7, spontaneous emission process). The main N_2 active species generated in plasma conditions and important for NF are listed in Table 2, together with possible mechanisms of their formation.

In contrast to “conventional chemistry,” the reaction rates of electron-involved processes in plasma chemistry are determined by a reaction threshold energy (in [eV]), cross-section (in [m^2]), and the electron energy distribution function, or T_e , if the Maxwell energy distribution approximation is fulfilled. The threshold energy depends on the nature of the heavy particles and determines the minimum energy of the electron to initiate the reaction. The cross-section defines the probability of the process and depends on the electron energy. Finally, the electron energy is determined by the reduced electric field (E/n), which is the ratio of the electric field E over gas number density n . Consequently, plasma chemistry can be precisely controlled by influencing the electron properties, which is exactly the aim of researchers working in the field of plasma chemistry: to control the plasma-initiated reactions through the tuning of plasma properties.

Table 1 Elementary processes in plasmas. P stands for process

Process		Scheme
P1	Momentum transfer	$AB + e^-(p_1) \rightarrow AB + e^-(p_2)$
P2	Electron dissociation	$AB + e^- \rightarrow A + B + e^-$
P2.1	Heavy particle dissociation	$AB^* + AB \rightarrow AB + A + B$
P3	Excitation	$AB + e^- \rightarrow AB^* + e^-$
P3.1	Electronic excitation	$AB(g, E_i) + e^- \rightarrow AB(E_j) + e^-$
P3.2	Vibrational excitation	$AB(g, \nu_i) + e^- \rightarrow AB(\nu_j) + e^-$
P3.3	Vibrational–vibrational energy exchange	$AB(\nu_i) + AB(\nu_j) \rightarrow$ $\rightarrow AB(\nu_i - n) + AB(\nu_j + m)$
P3.4	Vibrational–translational energy exchange	$AB(\nu_i) + M \rightarrow AB(\nu_i - n) + M$
P4	Electron ionization	$A + e^- \rightarrow A^+ + 2e^-$
P4.1	Ion induced ionization	$AB + C^+ \rightarrow AB^+ + C$
P4.2	Dissociative ionization	$AB + e^- \rightarrow A^+ + B + 2e^-$
P5	Dissociative attachment	$AB + e^- \rightarrow A^- + B$
P6	Detachment	$A + e^- \rightarrow A + 2e^-$
P7	Photon emission	$AB(E_j) \rightarrow AB(E_i) + h\nu$



Table 2 Overview table representing physical aspects of N₂ activation in plasma

Typical activated N species and their electronic configurations ⁴⁷					
N ₂		N		N ₂ ⁺	
Electronic state	Potential energy [eV]	Electronic state	Potential energy [eV]	Electronic state	Potential energy [eV]
N ₂ (X ¹ Σ _g ⁺ , ν)	0	N(S4)	0	N ₂ ⁺ (X ² Σ _g ⁺ , ν)	>15.45
N ₂ (X ¹ Σ _g ⁺ , ν = 1)	<0.3	N(D2)	2.39	N ₂ ⁺ (A ² Π _u , ν)	>16.5
N ₂ (A ³ Σ _u ⁺ , ν)	>6.17	N(P2)	3.57	N ₂ ⁺ (B ² Σ _u ⁺ , ν)	>18.35
N ₂ (B ³ Π _g , ν)	>7.35			N ₂ ⁺ (C ² Σ _u ⁺ , ν)	>23.2
N ₂ (C ³ Π _u , ν)	>11.03				

Nitrogen activation mechanisms in plasmas ^{47,62}			
Reaction	*- electronic configuration	Minimum activation energy [eV]	
Electron impact dissociation and excitation (dominant at E/n > 100 Td^a)			
e + N ₂ → N ^(*) + N ^(*) + e	(R2.1)		
	S4 + S4	9.75	
	D2 + S4	12.15	
	P2 + S4	13.3	
	D2 + D2	14.6	
Vibrational excitation, aka. vibrational ladder climbing (dominant at E/n < 100 Td)			
e + N ₂ → N ₂ [*] (ν > 0) + e	(R2.2)	(X ¹ Σ _g ⁺ , ν)	<0.29
e + N ₂ [*] (ν > 0) → N ₂ [*] (ν + n) + e	(R2.3)		
e + N ₂ (X ¹ Σ _g ⁺ , ν) → N + N ^(*) + e	(R2.4)		<9.75
N ₂ [*] (ν) + N ₂ [*] (ν) → N ₂ [*] (ν + n) + N ₂ [*] (ν - n)	(R2.5)		
Electronic excitation (dominant at E/n > 100 Td)			
e + N ₂ → N ₂ [*] + e	(R2.6)		
	A ³ Σ _u ⁺	6.17	
	B ³ Π _g	7.35	
	C ³ Π _u	11.03	
Ionization (dominant at E/n ≫ 100 Td)			
e + N ₂ → N ₂ ⁺⁺ + 2e	(R2.7)	(X ² Σ _g ⁺ , ν)	15.58
N ₂ [*] + N ₂ [*] → N ₂ ⁺⁺ + N ₂ + e	(R2.8)	(B ² Σ _u ⁺ , ν)	18.75
Photon excitation (dominant at E/n ≫ 100 Td)			
hν + N ₂ → N ₂ [*]	(R2.9)	≈ 200 nm	Also possible with multi-photon excitation
hν + N → N [*]	(R2.10)	≈ 103 nm	

^a 1 Td = 10²¹ V m⁻².

3.3 Advantages and limitations of plasma-based nitrogen fixation from a physical perspective

It is important to emphasize that in the context of NF, thermal plasmas, where the P1 process is dominant, cannot overcome the thermodynamic limit and so cannot compete with HB or other catalytical processes in terms of energy costs. A thermal arc was historically one of the first methods applied for industrial NF in 1903 (Norway). Birkeland and Eyde developed a method (BE) for the artificial synthesis of HNO₃ from atmospheric air using electrical arcs.^{48,49} Soon after their invention, the method was replaced by HB due to economic reasons mainly related to the high energy costs of the BE process. Indeed, the theoretical energy consumption minimum in thermal plasmas is 0.86 MJ mol⁻¹, which is almost twice the theoretical minimum of 0.48 MJ mol⁻¹ for HB.²⁹ Moreover, it can only be achieved at high pressure and a fast cooling rate of the gas (ca. 10⁷ K s⁻¹), preventing the reverse formation of initial

molecular components.^{29,35} Despite numerous efforts to optimize the arc reactor, the best performance obtained in thermal plasmas so far is 1.8–4.1 MJ mol⁻¹ (at different N₂:O₂ ratios and reactor configurations), which again makes it difficult to compete with HB on a large scale but still can be of interest for small scale production and use of abundant resources, *i.e.*, air as feedstock.⁵⁰

On the other hand, the advantage of non-thermal plasmas is related to the pathway of N≡N bond dissociation and the possibility of overcoming the energy efficiency of thermal processes because of unique chemistry realized under such conditions, namely at low *T_g* and high *T_e*. The N₂ dissociation limit is 9.7 eV, requiring very energetic electrons to be present in the discharge. This can only be achieved at very high *E/n* strength, which makes the process energy-demanding and inefficient from an industrial point of view. An alternative to this is the step-wise N₂ vibrational excitation. This mechanism



is initiated by low-energy electrons that can vibrationally excite N_2 (process P3.2 in Table 1). More importantly, these $N_2(v_i)$ states can also exchange energy (process P3.3 in Table 1), forming $N_2(v_j)$ with a high vibrational number ($j > i$). This process is called vibrational ladder climbing. The energy difference between low vibrational levels in $N_2(\Delta v_x = 1)$ is < 0.29 eV and decreases with every level according to the anharmonic oscillator theory.⁵¹ As a result of ladder climbing, the vibrationally excited states of N_2 generated because of P3.2 and P3.3 will induce an increase in the vibrational population of N_2 higher states that can efficiently drive NF, decreasing the N_2 dissociation limit. Very importantly, the N_2 vibrational states do not need to be in equilibrium with the rest of the gas, and so such a process can be driven by electron impact at low T_g . Therefore, NF driven by the vibrational ladder-climbing mechanism is superior to direct electron dissociation or thermal dissociation because:

- It requires low E/n strength, corresponding to a mean electron energy of about 2 eV, resulting in reasonable energy consumption;
- Vibrational excitation decreases the N_2 dissociation energy in electron impact reactions because the net reaction can take a path as follows: $N_2(v_x > 0) + e(E_e < 9.7 \text{ eV}) \rightarrow N + N^{(*)} + e$, where * stands for the energy surplus, which leads to the formation of an excited N atom.
- Finally, an important reaction for N_2 oxidation: $N_2 + O \rightarrow NO + N$, having E_a of 3.06 eV, can be initiated by vibrationally excited $N_2(v_x > 13)$. As such, the mechanism can be more energy efficient compared to direct dissociation.^{35,52–56}

Theoretical estimations based on the dissociation mechanism of N_2 by vibrational ladder climbing suggest that NF, namely oxidation, carried out *via* non-thermal plasmas can be 2.5 times more efficient than the currently used HB process (0.2

and 0.48 MJ mol⁻¹, respectively).^{29,35} This is the most important aspect of non-thermal plasma-induced NF, as the aforementioned mechanism provides a way to overcome the thermodynamic limit of thermal chemical processes, and so is able to compete with HB and other catalytic pathways. Unfortunately, vibrational ladder climbing is often coupled with vibrational energy relaxation in V-T processes (P3.4, Table 1), leading to gas heating and increasing the costs of $N \equiv N$ bond dissociation. Moreover, V-T relaxation accelerates with temperature and vibrational state numbers. This is why the most pronounced vibrational excitation is observed in low pressure plasmas, making it difficult to achieve at elevated pressure.^{35,57–59} However, a number of methods were proposed in the literature to reach high vibrational excitation of N_2 in plasmas operating at high pressure.^{54,58,60,61}

In summary, depending on the mean electron energy or T_e , plasma-induced NF processes can be dominated either by (i) elastic collisions, with typical examples of thermal plasmas; (ii) vibrational excitation, or (iii) electron impact dissociation. As the contribution of the listed processes is defined by the energy of the electrons, it can be tuned depending on a type of electrical discharge, more specifically depending on the value of E/n required to sustain the discharge and heat the electrons. In that regard, it is very convenient to classify electrical discharges based on their E/n value, as shown in Table 3. The electronically excited species (*e.g.*, $N_2(A, B, C)$) are typically produced under conditions when the E/n strength is >100 Td (in an N_2 atmosphere). This mechanism of N_2 excitation is dominant in dielectric barrier discharges (DBDs), corona discharges (where also photon-related processes take place), and short-pulse plasmas. At the same time, the favorable vibrational excitation, *i.e.*, $N_2(v_x)$ formation, can take place in plasmas operating at $E/n < 50$ Td. These are plasmas operating in glow discharge

Table 3 Typical physical characteristics of plasmas utilized for NF

Plasma type	Reduced electric field, E/n [Td]	Mean electron energy [eV]	Electron density, n_e [m ⁻³]	Gas temperature, T_g [K]	Dominant N_2 excitation pathway
Corona discharge (DC or pulsed)	$\gg 100$	>10	$10^{15}\text{--}10^{19}$	<400	Photoexcitation
DBD	>100	≈ 10	$10^{18}\text{--}10^{21}$	<700	Electronic excitation
Glow discharge	<50	1–2	$10^{19}\text{--}10^{21}$	300–1000	Electronic and vibrational excitation
Arc discharge (DC)	$\ll 10$	1–2	$10^{21}\text{--}10^{26}$	$T_e = T_g = 8000\text{--}14000$	Thermal excitation
Gliding arc (GA)	>100 at breakdown $\ll 100$ when sustained	1–2	$10^{20}\text{--}10^{22}$	2000–3500	Vibrational and thermal excitations
Spark discharge (AC, DC pulses)	$\gg 100$ at breakdown $\ll 100$ when sustained	<10 at breakdown 1–2 when sustained	$10^{21}\text{--}10^{24}$	>1000	Electronic, vibrational, and thermal excitations
MW plasmas	^a	^a	$10^{17}\text{--}10^{22}$	2400–10000	Dissociative excitation, vibrational, thermal excitations
RF discharges	^a	^a	$10^{21}\text{--}10^{26}$	$T_e = T_g = 600\text{--}3000$ K	
Pulsed RF	^a	^a		<400	
RF APPJ	^a	^a	$10^{17}\text{--}10^{18}$	<600	

^a Values strongly depending on the experimental arrangement; AC stands for alternating current; APPJ stands for atmospheric pressure plasma jet



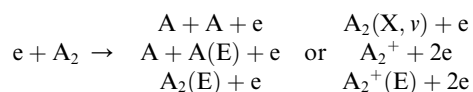
mode (mostly direct current (DC)), radiofrequency (RF), and MW plasmas. It is generally assumed that both electronic excitation and vibrational excitation can be initiated in pulsed plasmas (pulse duration from 10 μ s to 100 ms).^{62,63} At E/n below 5 Td, the contribution of elastic collisions starts to be dominant, and plasmas tend to transfer to thermal equilibrium. An overview of different plasma types used for NF is provided in Table 3.

In this section, the basic aspects of plasma physics in the frame of the NF approach were introduced, to help readers understand how different types of plasma can be used for the initiation of desirable chemistry. This knowledge is essential for any plasma researcher embarking on the design of plasma-based NF experiments. Armed with this knowledge, researchers can address key questions such as: What type of plasma should I use? What activated species does my plasma produce? What gas temperature and degree of non-equilibrium can I achieve? To provide a guideline in answering such key questions, the following sections will discuss the current state-of-the-art in two primary directions: N_2 oxidation and N_2 reduction, with a focus on mechanisms of reactions initiated by plasma.

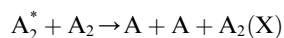
4 Plasma nitrogen fixation: chemistry

This section explores the chemical pathways involved in nitrogen fixation, specifically focusing on the nitrogen oxidation and reduction processes in various gas atmospheres. Before delving into these processes, it is essential to establish the foundational concepts, including the common logic, terminology, and denotations used throughout the discussion.

In general, plasma-based NF starts with feedstock activation through a reaction between energetic electrons and heavy particles or between several heavy particles with redundant energy. These processes depend on the gas mixture composition and can be generally introduced as follows:



Further, for contingency, all electronically excited states (E) and vibrationally excited states (X, ν) will be denoted with an asterisk *, while an asterisk enclosed in brackets, (*), will mean a species that can be in ground as well as in excited state,



There is no general agreement on the importance of each activation channel facilitating NO_x and especially NH_3 synthesis. Direct electron impact dissociation,⁶⁴ ionization,^{64,65} electronic excitation,^{64,66,67} and vibrational excitation^{68,69} have all been proposed as important mechanisms taking place in different plasmas.⁷⁰ However, it is well accepted that the larger the contribution of vibrational excitation in N_2 dissociation, the more energy-efficient the NF. In turn, the gas-activated species initiate the formation of initial products, for example as:



As a final step, further oxidation or hydrogenation takes place for N_2 oxidation and N_2 reduction processes, respectively.

The overall rate-determining and most energy-consuming step of NF in the plasma environment is electron impact activation of the N_2 molecule, *i.e.*, (R2.1)–(R2.10) reactions in Table 2. Such an initial step is common for all plasma-based NF processes, oxidation or reduction, but the plasma type determines selectivity towards the generation of specific intermediates and so the final reactive species. It must also be emphasized that the mechanisms discussed in Sections 3.1 and 3.2 serve only the purpose of introducing divergence in NF chemistry. From this perspective and the purpose of the paper, they are given in a very generalized way (although supported by literature and reaction rate analysis), while real chemistry is much more complicated and may involve thousands of reactions from radical chemistry, photochemistry, *etc.*, but discussing these would lie outside the scope of our discussion.

4.1 Plasma nitrogen fixation: oxidation pathways

The following section introduces readers to the key chemical reaction pathways leading to (H)NO_x synthesis. It is organized by the type of feedstock used, allowing readers to focus on the processes most relevant to their interests.

The understanding of N_2 oxidation mechanisms has been built upon the combustion processes. N_2 oxidation chemistry at thermal conditions (in combustion) has been well-known since the 1940s and is described below *via* reactions (R3.1)–(R3.3), known as the extended Zeldovich mechanism.⁷¹



Reaction (R3.1) is the rate-determining step due to the need to break the strong triple bond of the N_2 molecule. As such, in combustion, the final concentration of NO is notably influenced by the composition of the fuel mixture and the temperature used. In O_2 -rich gas mixtures, the NO concentration reaches equilibrium through the reversible reaction (R3.2). This entails a forward reaction at low NO concentrations and a reverse reaction at higher NO concentrations. However, under specific conditions, particularly when the oxygen content is low in the gas mixture, the NO concentration is governed by reaction (R3.3), which involves OH radicals. The latter can be generated in significant quantities within the combustion mixture through the oxidation of hydrocarbons (the fuel).^{71–73}

Building upon initial attempts in NO_x synthesis at plasma conditions *via* the thermal Birkeland–Eyde process and emerging insights into NO formation chemistry from combustion studies, a broad range of plasma sources have been explored for the dissociation and oxidation of the $N \equiv N$ bond.³⁵ Several literature reports delve into the underlying oxidation



pathways.^{17,62,74–79} The chemistry of N₂ oxidation differs significantly and exhibits greater diversity in plasma compared to combustion, owing to the non-equilibrium conditions that can be realized in plasmas.

4.1. 1 Nitrogen oxidation in N₂ + O₂ (air) systems. NO_x formation requires a source of N and O. Air is the most obvious choice of feedstock owing to its abundance and accessibility. In dry N₂:O₂ gas mixtures, NO_x formation can be described following the aforementioned steps: activation – initial product formation – oxidation, as shown in Table 4 and schematically illustrated in Fig. 2a.

The plasma type strongly affects the occurring chemistry, namely during feedstock activation ((R2.1)–(R2.10) for N₂ and (R3.4)–(R3.7) for O₂, Tables 2 and 4, respectively) and precursor formation steps (R3.8) and (R3.9). Plasmas with high electric field, *i.e.*, $E/n > 100$ Td (such as a DBD), generate electronically excited species, while plasmas with $E/n < 100$ Td can initiate strong vibrational excitation (see Table 2 for details). In general, the generation of NO, a primary precursor for the formation of further, higher oxides, happens *via* the so-called non-thermal Zeldovich mechanism. This term is often met in the plasma community, and it refers to reactions (R3.8) and (R3.9) driven by highly reactive species formed in plasma.

It is also generally accepted that the most energy-efficient pathway for NF is promoted by vibrational excitation of ground state to N₂(X, ν) (see Section 2). Vibrational excitation decreases the activation energy barrier for nitrogen dissociation, facilitating reaction (R2.1) through (R2.5), as shown in Table 2. More importantly, for N₂ oxidation, the Zeldovich mechanism can be efficiently exploited by overpopulating the N₂ vibrational levels, and reaction (R3.1), shown earlier, can be driven by N₂(X, $\nu > 13$). However, often, vibrational excitation is suppressed by undesirable V–T energy transfer processes, which lead to a rise in gas temperature, inherently initiating NO formation following the thermal Zeldovich mechanism (R3.1) and (R3.2). This means that in warm plasmas (with $E/n < 100$ Td, such as GA), NO generation can occur through a combination of both non-thermal and thermal Zeldovich mechanisms. In this case, NO formation *via* thermal mechanism can be considered a waste of energy because it is less efficient than its non-thermal counterparts. In addition, the reverse processes (R3.8) and (R3.9) become more pronounced at high temperatures, restricting NO formation (red arrows pathway in Fig. 2a). Therefore, the specific contribution of non-thermal and thermal Zeldovich mechanism in plasmas with $E/n < 100$ Td remains uncertain and subject to ongoing scientific debate.

The ultimate oxidation of NO to NO₂ is shown in reactions (R3.10) and (R3.11). Ozone (O₃) production primarily occurs through the reaction O₂ + O + M → O₃ + M, which consumes reactive oxygen atoms (M stands for the third body). O₃ is crucial for the formation of NO₂; nevertheless, in plasmas with elevated gas temperatures, the significance of (R3.11) diminishes as O₃ becomes unstable at high temperatures (green arrows pathway in Fig. 2a). It is worth noting that reaction N + O₃ → NO + O₂ cannot contribute at the initial oxidation state stage due to its low reaction rate constant.⁸⁰

Table 4 Plasma-based N₂ oxidation

Nitrogen oxidation in N ₂ + O ₂ (air) mixtures	
Feedstock (N₂, O₂) activation (N, N*, N₂[*], O, O*, O₂[*])	
(R2.1)–(R2.10) (N ₂ activation, as described in Table 2)	
e + O ₂ → O + O* + e	(R3.4)
e + O → O* + e	(R3.5)
e + O ₂ → O ₂ [*] + e	(R3.6)
N ₂ [*] + O ₂ → O + O* + N ₂ ^(*)	(R3.7)
Initial oxidation of N	
N ₂ [*] + O → NO + N	(R3.8)
N ^(*) + O ₂ [*] → NO + O	(R3.9)
Further N oxidation	
NO + O + M → NO ₂ + M	(R3.10)
NO + O ₃ → NO ₂ + O ₂	(R3.11)
Decomposition reaction of NO _x	
NO _x + O + M → NO _{x-1} + O ₂ + M	(R3.12)
Nitrogen oxidation in N ₂ + H ₂ O and N ₂ + O ₂ (air) + H ₂ O mixtures	
Feedstock (N₂, O₂, H₂O) activation (N, N*, N₂[*], O, O*, O₂[*], OH, H) in the gas phase	
(R2.1)–(R2.10) (N ₂ activation, as described in Table 2)	
(R3.4)–(R3.7) (O ₂ activation)	
e + H ₂ O → OH + H + e	(R3.13)
O* + H ₂ O → OH + OH	(R3.14)
N ₂ [*] + H ₂ O → N ₂ + H + OH	(R3.15)
H ₂ O $\xrightarrow{\text{UV irradiation 120–170 nm}}$ OH + H	(R3.16)
e + OH → H + O + e	(R3.17)
Initial oxidation of N: (R3.8) and (R3.9)	
N* + OH → NO + H	(R3.18)
Further N oxidation: (R3.10) and (R3.11)	
NO + H + M → HNO + M	(R3.19)
NO ₂ + HNO + M → HNO ₂ + NO + M	(R3.20)
NO + OH + M → HNO ₂ + M	(R3.21)
H ₂ O + NO ₂ → OH + HNO ₂	(R3.22)
H ₂ O + NO ₂ + NO → HNO ₂ + HNO ₂	(R3.23)
Feedstock (N₂, O₂, H₂O) activation (N, N*, N₂[*], O, O*, O₂[*], OH, H) in the plasma/liquid interface	
(R2.1)–(R2.10) (N ₂ activation described in Table 2)	
(R3.4)–(R3.7) (O ₂ activation)	
(R3.13)–(R3.17) (H ₂ O activation)	
OH + OH → H ₂ O ₂	(R3.24)
H ₂ O ₂ + O → HO ₂ + OH	(R3.25)
OH + O ₃ → HO ₂ + O ₂	(R3.26)
OH + H ₂ O ₂ → HO ₂ + H ₂ O	(R3.27)
Initial oxidation of N in the plasma/liquid interface: (R3.8), (R3.9) and (R3.18)	
N + HO ₂ → NO + OH	(R3.28)
Further N oxidation in the plasma/liquid interface: (R3.10), (R3.11), (R3.19)–(R3.23)	
NO ₂ + O + M → NO ₃ + M	(R3.29)
HO ₂ + NO ₂ → HNO ₂ + O ₂	(R3.30)
OH + NO ₂ + M → HNO ₃ + M	(R3.31)
H ₂ O ₂ + NO ₂ + NO ₂ → HNO ₃ + HNO ₃	(R3.32)
HO ₂ + NO + M → HNO ₃ + M	(R3.33)

The effect of the N₂ : O₂ ratio on the production rate (PR) and energy cost was investigated in various plasma systems, including MW, DBD, nanosecond pulse plasma, and GA.^{50,59,62,81} The best performance is consistently achieved with a gas





Fig. 2 Reaction diagrams of the N_2 oxidation processes in (a) $\text{N}_2 : \text{O}_2$ (air), (b) $\text{N}_2 + \text{H}_2\text{O}$ and $\text{N}_2 + \text{O}_2$ (air) + H_2O feedstocks, where (c) highlights the chemistry in the plasma/liquid interface. Black, blue, red, and green arrows indicate electron impact reactions, forward reactions, reverse reactions at high temperature, and reactions pronounced at low temperature, respectively.

mixture ratio of 1 : 1 (rather than 4 : 1 as in air). However, the enhancement in the yield of oxidation products is not significant, considering the energy expenses associated with the production of either pure N_2 or O_2 .

The most industrial-relevant question is achieving the theoretical minimum EC of NF. It can be realized by utilizing the non-thermal Zeldovich mechanism, which is a key objective in the plasma community. Alongside direct NO_x formation, two common challenges are:

- Minimizing its decomposition *via* reverse reactions;
- Maximizing the fraction of gas treated by the plasma.^{48,50,74,82}

These issues are often addressed by using pulsed spark plasmas,^{83,84} incorporating specialized output gas nozzles

(utilizing the adiabatic and Joule–Thomson effects to cool the gas through expansion),^{85–87} modifying the gas flow dynamics,^{85,87} and introducing increased pressure to favor NO oxidation into NO_2 rather than NO_x decomposition (*i.e.*, favoring (R3.10) over (R3.12)).⁴⁹ It is, however, important to note that the produced NO_x species are not fertilizers but rather fertilizer building blocks.

4.1.2 Nitrogen oxidation in $\text{N}_2 + \text{H}_2\text{O}$ and $\text{N}_2 + \text{O}_2$ (air) + H_2O systems. While publications on wet N_2 oxidation and N_2 reduction are relatively sparse compared to dry systems, interest in such processes has been increasing over the last 10 years. This rise is due to water being a green counterpart of CH_4 or H_2 , providing H.^{88,89} For NF, water serves as a source of either O or O/H needed for NO_x or HNO_x formation, respectively (in this



case, the reduction process can also take place, which will be discussed in the following section). It has to be noted that from an application point of view, the $N_2 + H_2O$ gas mixture is not very practical for N_2 oxidation because pure N_2 is a feedstock with added costs, and it requires pressure swing adsorption for separation from the air, and the absence of O_2 obviously reduces the contribution of the N_2 oxidation pathway in NF. Studies of $N_2 + H_2O$ systems mostly aim to define the role of water in NF by reducing the number of reactants, *i.e.*, simplifying the chemistry.

When liquid H_2O is introduced into the system, NF products accumulate in the liquid phase. These products may include NH_3 in the form of NH_4^+ , as well as oxidation products of nitrogen, such as nitrite (NO_2^-) and nitrate (NO_3^-) ions. Therefore, the plasma-based synthesis of reactive oxygen species (ROS) and reactive nitrogen species (RNS) in water is often referred to as plasma-treated water (PTW) or plasma-activated water (PAW).⁹⁰

There is no general agreement on the reaction locus for NO_x formation in the presence of H_2O . Opinions are divided among the gas phase, plasma-liquid interface, and liquid phase. It is well known that an increase in NF species production rate can be achieved by increasing the plasma-liquid surface area.⁹¹ Considering this, designs with an increasing interface surface have been intensively studied: aerosol droplets,⁹² water film, and vapour.^{91,93} The source of the reactive species responsible for plasma-liquid chemistry is still under debate. In the case of plasma jets interacting with liquid water, the contradictory findings by various research groups indicate that there may or may not be a direct interaction of plasma with molecules of liquid water. The formation of NH_x (which will be discussed in Section 3.2) and NO_x species by N_2 -containing plasma over water was suggested to occur (1) in the gas phase from the evaporated water^{92,93} or (2) through direct interaction of plasma species with the top layer molecules of liquid H_2O .^{94,95} Thus, the nature of plasma interaction with liquid likely depends on the specific plasma-liquid system, including the properties of the gaseous discharge and the geometry of the plasma-liquid interface.

Overall, conclusions about the reaction locus strongly depend on the reactor arrangement and the way water is introduced. Given that NF chemistry in the presence of H_2O is still under debate, it will be discussed considering distinguishable cases: (i) water in the gas phase, (ii) plasma-liquid interface, and (iii) in the bulk.

Fig. 2b depicts the NF oxidation chemistry in the presence of water, underlying the changes in the chemistry compared to the dry $N_2 : O_2$ case in color. For both $N_2 : O_2 + H_2O$ and $N_2 + H_2O$ systems, the feedstock activation stage is the same, and H_2O homolytically dissociates into H and OH ((R3.13), see Table 4) under the electron impact and reactions with electronically excited states of N_2^* (and O^* , in the case of $N_2 : O_2 + H_2O$, (R3.15) and (R3.14), respectively).^{96,97} Photodissociation of H_2O (R3.16) may also take place in plasmas, especially when using high E/n values, such as in the case of corona or DBD.⁹⁸ Furthermore, the full dissociation of H_2O into H and O may also be considered following reaction (R3.17). However, the probability of this

latter process is likely small because of two main reasons. Firstly, it involves a two-step process: two electron impact reactions (R3.13) and (R3.17) or heavy-particle (R3.14) or (R3.15) and electron impact (R3.17). Secondly, the reaction rate will be determined by the concentration of reactants, especially OH and electrons, which may be in limited supply. The concentration of the latter strongly depends on the plasma type ($n_e(\text{DBD}) \ll 10^{21} \text{ m}^{-3}$, and $n_e(\text{spark}) < 10^{24} \text{ m}^{-3}$, at atmospheric pressure conditions).

In the gas phase, NO formation should dominantly follow the reactions (R3.8), (R3.9) and (R3.18). However, in the $N_2 + H_2O$ gas medium, the precursor formation process (R3.9) is significantly suppressed due to the lack of O_2 in the gas mixture but can be replaced through (R3.18), involving OH radicals, as highlighted in Fig. 2b. The effect of the latter on NO formation in the gas phase has been shown through experiments in many studies.^{62,81,92,97,99–102}

In addition to (R3.10) and (R3.11), further N oxidation processes can be enhanced by the reactions (R3.19)–(R3.23). In the $N_2 + H_2O$ gas mixture, due to a shortage of O/O_2 , the selectivity of stable products is strongly shifted towards HNO_2 formation because further N oxidation is mostly governed by OH radicals (R3.21).¹⁰³ Several important points should be noted here. Due to its high reactivity, among different products of the NF process, HNO cannot be isolated as a product. It reacts rapidly with other molecules or undergoes decomposition into simpler compounds. Therefore, HNO is primarily encountered as an intermediate in chemical reactions. Nitric acid (HNO_3) formation in the gas phase can occur only under very specific conditions, such as low pressure and temperature. At atmospheric pressure in the gas phase, HNO_3 can be formed as $OH + NO_2 + M \rightarrow HNO_3 + M$ with $k(298 \text{ K}) = 4.75 \times 10^{-11} \text{ cm}^3 \text{ s}^{-1}$ (reduced to the second-order reaction),⁸⁰ which decreases with temperature, slowing it down. Meanwhile, one of the major HNO_3 removal processes, namely $OH + HNO_3 \rightarrow H_2O + NO_2$, has $k(298 \text{ K}) = 2 \times 10^{-13} \text{ cm}^3 \text{ s}^{-1}$ ¹⁸⁰ and exponentially increases with temperature. Therefore, HNO_3 is unstable and prone to decompose, ending up as NO_2 . The same effect can take place with NO_3 , whose removal processes, namely $NO_3 + O \rightarrow O_2 + NO_2$ and $NO + NO_3 \rightarrow NO_2 + NO_2$, are faster than the formation ones.

The NF chemistry at the plasma/liquid interface remains unclear and has yet to be completely revealed. The lack of systematic studies is the primary reason for this uncertainty. Most research focuses on the behavior of a few radicals, neglecting the full range of possibilities. Additionally, studies of chemical pathways are often lacking due to the absence of thorough computational chemical modeling. The lack of necessary reaction rate constants (or their high uncertainty), as well as the difficulty in matching three different phases where water exists in different states (gas phase – vapor, plasma/liquid interface – mist, liquid phase – water bulk), are major obstacles preventing the development of a chemical kinetics model for plasma-liquid systems. While some works address the chemistry in such systems, focusing on gas chemistry, plasma/liquid interface chemistry, and liquid chemistry separately, much more research is needed for further advancements.^{104,105}



Fig. 2c shows N_2 oxidation chemistry in the plasma/liquid interface. Due to the high concentration of gaseous H_2O at the plasma/liquid interface region, its activation following reactions (R3.13)–(R3.17) becomes more significant than in the gas phase, increasing OH concentration. Moreover, this activation can significantly enhance the production of reactive species such as hydroxyl peroxide (H_2O_2) and hydroperoxyl radical (HO_2) *via* reactions (R3.24)–(R3.27). The latter opens an additional pathway for precursor formation, namely NO (R3.28). Finally, the abundance of OH, H_2O_2 , and HO_2 can further boost HNO_2 formation (R3.30) and, more importantly, facilitate the formation of HNO_3 through reactions (R3.31)–(R3.33) at the plasma/liquid interface. Besides these often addressed reactions, the possibility of other reactions, such as $NO + OH^-$, is unknown, requiring further investigation.⁹⁸

The plasma/liquid interface primarily serves as the site for solvation reactions, following Henry's law. The solubility of (H) NO_x components, arranged from weakest to strongest, follows $NO \rightarrow NO_2 \rightarrow NO_3 \rightarrow HNO_2 \rightarrow HNO_3$. Considering the high Henry's constants of HNO_3 and NO_3 , the plasma/liquid interface can indeed be regarded as the crucial site for their formation (R3.29), (R3.31)–(R3.33), where they are initially generated and then solvated.

The products of N_2 oxidation in liquids are NO_2^- and NO_3^- ions. Liquid-phase chemistry in this context has been extensively researched, with numerous reviews available on this topic.^{98,106–108} However, uncertainty persists regarding the reaction pathways that lead to the formation of these products. The liquid phase becomes increasingly dominated by NO_2^- in plasmas with high concentrations of HNO_2 and NO in the gas phase, achievable in $N_2 + H_2O$ and dry $N_2 : O_2$ feedstocks, respectively. Meanwhile, the selectivity shift toward NO_3^- is pronounced in plasmas with large plasma/liquid interface area, due to the elevated solubility of HNO_3 and NO_3 and at increased concentrations of NO_2 . The latter, high NO_2 concentrations, is most pronounced in dry $N_2 : O_2$ plasmas, reaching 50–70% selectivity, and can be further enhanced up to 100% by introducing an additional oxidation source, such as ozone, or performing the synthesis at elevated pressure.^{50,109}

In line with the objective of this work, focusing on plasma-based NF for fertilizer production, it is imperative to maintain a low concentration of NO_2^- in the output solution due to its detrimental effects on plants. Elevated NO_2^- levels can disrupt various cellular processes and inhibit essential enzymes, leading to oxidative stress, chlorosis (yellowing of leaves), and even plant death. From a chemical perspective, the most efficient method to convert NO_2^- present in the output into NO_3^- is through reaction with H_2O_2 . The latter can be effectively generated in plasmas with electronic excitation at low gas temperatures. In warm plasmas, such as GA ($E/n < 100$ Td), the high temperature inhibits H_2O_2 generation. In such cases, NO_2^- can be converted into NO_3^- by bubbling O_2 gas through the liquid.

To summarize, plasma-based nitrogen oxidation is typically carried out in a dry $N_2 : O_2$ (air) atmosphere, resulting in NO_x production, or $N_2 : O_2$ (air) + H_2O or $N_2 + H_2O$ atmospheres, leading to the formation of (H) NO_x . It is important to note that

in the latter cases, product formation occurs in both gas and liquid phases, which must be considered during analysis. Using $N_2 + H_2O$ feedstock represents mainly a scientific interest in determining the chemical reaction pathways due to the high cost of pure N_2 . Similar to the Oswald process (R1.2)–(R1.5), the ultimate aim of plasma-based nitrogen oxidation for fertilizer production is to generate HNO_3 . This is achievable only if HNO_3 is preserved in the liquid phase as NO_3^- , making the selectivity of its generation crucial. The most efficient performance in terms of EC is attainable in plasmas with significant vibrational excitation of N_2 , as shown in Table 6. However, while the presence of the liquid phase is essential for the accumulation of NO_3^- , the plasma–liquid interface can adversely affect the NF process from a physical standpoint. Firstly, the presence of water vapor can diminish vibrational excitation, thereby hindering the activation of N_2 molecules.^{78,110} Secondly, the activation of water (R3.13)–(R3.17) is energy-intensive, diverting electron energy away from NF, specifically N_2 activation. Finally, the presence of a plasma–liquid interface involves the transfer of H_2O from the liquid to the gas phase (evaporation), where electrons can react with it, further increasing the energy demands of the process. From a chemical kinetics standpoint, N_2 oxidation in the presence of water can provide extra pathways for NO_x generation and shift process selectivity towards HNO_x formation. At the same time, the chemistry becomes diverse and more complicated, as visually seen in Fig. 2. The formation of numerous components in the system can lead to electron energy losses during their formation and subsequent excitation. Thus, N_2 oxidation in the presence of a plasma–liquid interface can significantly alter process selectivity, while simultaneously leading to a notable reduction in process energy efficiency (by some estimates up to 20%).¹⁰¹

4.2 Plasma nitrogen fixation: reduction pathways

This section provides an overview of nitrogen reduction, focusing on the synthesis of NH_3 (or NH_4^+ in the liquid medium). The process has been less explored due to several fundamental and practical challenges, which will be discussed in detail within each sub-section, focusing on nitrogen reduction in different feedstocks.

NH_3 synthesis in conditions of electrical discharge has been conducted utilizing different N- and H-containing feedstocks introduced as gases (N_2 , $N_2 + O_2$ (air), H_2 , H_2O , CH_4 , alcohols) and liquids (H_2O , alcohols). The presence of different phases does not bring consensus on the reaction mechanisms for NH_3 formation. Opinions are divided between the liquid phase,^{111–114} gas phase,^{115,116} catalyst surface,¹¹⁶ or the gas/liquid^{111,114} interface, based on the focus of the research.

Generalizing, plasma-based NH_3 formation chemistry follows similar basic steps as NO_x generation: feedstock activation, formation of initial products, and further hydrogenation. In the context of N_2 reduction, the use of a catalyst can significantly promote precursor formations *via* heterogeneous processes on the surface of catalysts through Eley–Rideal or Langmuir–Hinshelwood mechanisms.¹¹⁷ The latter is of particular interest because, in this case, the catalyst surface acts as



a “trap” for activated species, followed by their reaction to form products and their later desorption from the surface.¹¹⁸ It is often hypothesized that a synergistic combination of a non-equilibrium plasma and catalysis affords higher reaction productivity than conventional thermal catalysis.^{118,119} However, the presence of a catalyst in the plasma zone can significantly impact the plasma properties, making plasma-catalytic processes interconnected, which is often not considered despite its crucial importance, as it strongly influences the plasma power density and, consequently, the chemistry and process efficiency.^{120,121}

NH₃ (or NH₄⁺ in liquid) synthesis can be performed using different feedstocks. In the subsequent sections, the main reaction pathways leading to N₂ reduction in various plasma forming gases are summarized.

4.2.1 Nitrogen reduction in N₂ + H₂ mixtures. Direct NH₃ synthesis from N₂ and H₂ mixtures is an exothermic reaction, therefore favored at low temperatures. However, the dissociation of N₂ is a strongly endothermic reaction, which requires high energy input. The latter can be achieved by several approaches. The first two are high temperature or high vibrational excitation (see previous Sections for details).^{122–125} In terms of NH₃ formation, high temperatures must be avoided because NH₃ molecules become unstable at 973 K at 1 atm. Considering this, mostly DBD plasmas are used owing to their strong non-equilibrium nature (*i.e.*, low T_g and dominant electron excitation and dissociation).⁵⁷ In this case, the NH₃ formation pathway can be described as feedstock activation ((R2.1)–(R2.10) for N₂ and (R3.34)–(R3.36) for H₂, Tables 2 and 5, respectively), initial reduction ((R3.37)–(R3.40), Table 5), and further hydrogenation processes ((R3.41)–(R3.44), Table 5), as illustrated in Fig. 3a.

N₂ reduction processes can be significantly reinforced using a combination of non-thermal plasmas and a catalyst. In this case, conceptually, the chemistry remains the same but is shifted onto the catalyst surface, improving reaction activity and selectivity. Hence, the aforementioned reactions, specifically activation, and further hydrogenation stages, dominantly take place in accordance with Eley–Rideal and Langmuir–Hinshelwood mechanisms (with the main mechanism depending on the nature of the active metal site^{126,127}).

Plasma-based NH₃ synthesis in an N₂ + H₂ gas mixture is of fundamental research interest because it contradicts the concept of plasma-based NF. The utilized gases, N₂ and H₂, are relatively expensive feedstocks, *i.e.*, more expensive than simple air needed for NO_x generation, as described in Section 3.1. Therefore, further utilization seems to be hindered by this.¹²⁸ Nonetheless, such studies help to understand the chemistry of NH₃ formation and assess the importance of the heterogeneous process on the catalyst surface. The overall performance of such systems in terms of EC [MJ mol⁻¹] and PR [mg h⁻¹] is concatenated in Table 6. Evidently, the use of a catalyst appears beneficial for process performance, allowing a decrease in EC and a significant gain in PR (note that PR for catalytic systems is reported in mg per h per gram of catalyst).

4.2.2 Nitrogen reduction in N₂ + H₂O mixtures. Another interesting concept receiving a lot of attention is the use of H₂O

Table 5 N₂ reduction pathways in different feedstock systems

Nitrogen reduction in N ₂ + H ₂ mixtures	
Feedstock (N₂, H₂) activation (N, N[*]N₂[*], N₂⁺, H, H[*], H₂[*])	
(R2.1)–(R2.10) (N ₂ activation, as described in Table 2)	
e + H ₂ → H + H [*] + e	(R3.34)
e + H ₂ → H ₂ [*] + e	(R3.35)
N ₂ [*] + H ₂ → H + H [*] + N ₂	(R3.36)
Initial reduction of N	
N + H → NH	(R3.37)
N [*] + H ₂ → NH + H	(R3.38)
N + H ₂ [*] → NH + H	(R3.39)
N ₂ [*] + H → NH + N	(R3.40)
Further hydrogenation	
NH + H ₂ [*] → NH ₂ + H	(R3.41)
NH + H → NH ₂	(R3.42)
NH ₂ + H ₂ [*] → NH ₃ + H	(R3.43)
NH ₂ + H → NH ₃	(R3.44)
Nitrogen reduction in N ₂ + H ₂ O mixtures	
Feedstock (N₂, H₂O) activation (N, N[*], N₂[*], N₂⁺, H, H[*], H₂[*], OH, H₂O[*])	
(R2.1)–(R2.10) (N ₂ activation, as described in Table 2)	
(R3.13)–(R3.17) (H ₂ O activation, as described in Table 4)	
Initial reduction of N: (R3.37), (R3.40)	
N + OH → NH + O	(R3.45)
N ₂ [*] + H ₂ O → NH + N + OH	(R3.46)
Further hydrogenation: (R3.42), (R3.44)	
NH + OH → NH ₂ + O	(R3.47)
NH ₂ + OH → NH ₃ + O	(R3.48)
Decomposition reaction of NH _x in the presence of water	
OH + NH → H + HNO	(R3.49)
OH + NH ₂ → H ₂ O + NH	(R3.50)
OH + NH ₃ → H ₂ O + NH ₂	(R3.51)
Nitrogen reduction in N ₂ + CH ₄ mixtures	
Feedstock (N₂, CH₄) activation (N, N[*], N₂[*], N₂⁺, H, H[*], H₂[*], CH₃, CH₂, CH, CH[*])	
(R2.1)–(R2.10) (N ₂ activation, as described in Table 2)	
e + CH ₄ → products (CH ₃ , CH ₂ , CH, H, H ₂ , C) + e	(R3.52)
N ₂ [*] + CH ₄ → CH ₃ + H + N ₂	(R3.53)
Initial reduction of N: (R3.37) and (R3.40)	
N [*] + CH _x → CH _{x-1} + NH	(R3.54)
N [*] + CH ₂ [*] → HCN + NH	(R3.55)
N [*] + CH → C + NH	(R3.56)
Further hydrogenation: (R3.42) and (R3.44)	
CH ₄ + NH → CH ₃ + NH ₂	(R3.57)
CH ₄ + NH ₂ → CH ₃ + NH ₃	(R3.58)
HCN formation (dangerous but value-added chemical (NOT FOR NF))	
CH ₃ + N → HCN + H ₂	(R3.59)
CH ₂ + N → HCN + H	(R3.60)
Nitrogen reduction in N ₂ + EtOH mixtures	
Feedstock (N₂, C₂H₅OH) activation (N, N[*], N₂[*], N₂⁺, H, H[*], H₂[*], CH₃, CH₂, CH, CH[*])	
(R2.1)–(R2.10) (N ₂ activation, as described in Table 2)	
CH ₃ CH ₂ OH + e/N ₂ [*] → CH ₃ CH ₂ O + H + e/N ₂	(R3.61)
CH ₃ CH ₂ OH + e/N ₂ [*] → CH ₃ CHOH + H + e/N ₂	(R3.62)
CH ₃ CH ₂ OH + e/N ₂ [*] → CH ₂ CH ₂ O + H + e/N ₂	(R3.63)
CH ₃ CH ₂ OH + e/N ₂ [*] → CH ₃ CH ₂ + OH + e/N ₂	(R3.64)
CH ₃ CH ₂ OH + e/N ₂ [*] → CH ₃ + CH ₂ OH + e/N ₂	(R3.65)
Initial reduction of N: (R3.37), (R3.40), (R3.3.45) and (R3.54)–(R3.56)	



Table 5 (Contd.)

Nitrogen reduction in N ₂ + EtOH mixtures	
CH ₃ CH ₂ + N* → NH + CH ₂ CH ₂	(R3.66)
CH ₃ CH ₂ OH + N* → NH + CH ₃ CHOH	(R3.67)
Further hydrogenation: (R3.42), (R3.44), (R3.47), (R3.48), (R3.57) and (R3.58)	
CH ₂ O + NH ₂ → HCO + NH ₃	(R3.68)
Reverse processes in an N ₂ + C _x H _y O _z system	
C ₂ H ₅ + NH ₂ → C ₂ H ₆ + NH	(R3.69)
CH ₃ O + NH ₃ → CH ₃ OH + NH ₂	(R3.70)

either as a gas, liquid, or vapour as an abundant, green H source for the N₂ reduction process.^{108,142} Fig. 3b shows the basic steps leading to NH₃ formation in the N₂ + H₂O system. In this case, thermal plasmas have been found to be more useful, *e.g.*, in treating a liquid surface.¹⁰⁸ The N₂ and H₂O activation as well as the precursor formation can occur in the thermal region of the plasma, while hydrogenation may occur in the low-temperature

afterglow. The N₂ activation will follow the reactions (R2.1)–(R2.10) (see Table 2) but predominantly through the interaction with vibrationally excited N₂(X, v). It is important to note that in the absence of O₂, H₂O also simultaneously plays the role of O and H source. Therefore, in N₂ + H₂O systems, two sets of processes can occur: N₂ reduction, as discussed here, and N₂ oxidation (as previously discussed in Section 3.1).

As mentioned above, for systems with H₂O, the reaction locus is a subject of debate and likely depends on a specific plasma–liquid configuration. Still, in the case of systems comprised of plasma interacting with a liquid interface, extracting H from the liquid surface is considered the rate-limiting step for NH₃ formation in plasma–liquid systems.⁹¹ To overcome this limitation, an additional activation mechanism *via* ultraviolet (UV) radiation of the water surface is a way used to increase the available H⁺ at the plasma/liquid interface through H₂O_{aq} → H_{aq}⁺ + OH_{aq}⁻ (120–170 nm, (R3.16) in Table 4), resulting in a more efficient hydrogenation. It can increase NH₄⁺ formation (up to 4 fold) compared to conditions without UV.^{91,95,113}



Fig. 3 Reaction diagrams of the N₂ reduction processes in (a) N₂ : H₂, (b) N₂ + H₂O, (c) N₂ + CH₄, (d) and N₂ + EtOH feedstocks. Black, blue, and yellow arrows indicate electron impact reactions, forward reactions, and reverse reactions, respectively.



Table 6 Typical examples of plasma NF processes and their metrics (energy cost, production rate)

Type of NF	Plasma type	Energy cost [MJ mol ⁻¹]		Production rate [mg h ⁻¹]		Employment details
		NH ₃	NO _x	NH ₃	NO _x	
N₂ + O₂(air)						
Oxidation	Pulsed DC spark ⁸³	—	0.4	—	300	In air
	DC glow ¹²⁹	—	2.8	—	1900	In air
	Low-current coaxial plasmatron ¹³⁰	—	3.4	—	3000	In air
	Thermal arc ¹³¹	—	10.5	—	128 000	In air
	Rotating GA ⁵⁰	—	2.3	—	32 000	In air. 3 barg
	Rotating GA ⁵⁰	—	1.8	—	68 900	N ₂ :O ₂ 1:1.3 barg
N₂ + H₂						
Reduction	DBD ¹³²	102	—	154	—	No cat
	DBD + cat ¹³³	437	—	8 ^a	—	Ni/Al ₂ O ₃ cat
	DBD + cat ¹³⁴	74	—	25.5 ^a	—	Co-Ni/Al ₂ O ₃ cat
	DBD + cat ¹³⁵	32	—	38 ^a	—	Ru/Al ₂ O ₃ cat
	DBD + cat ¹³⁶	58	—	75 ^a	—	Ni-Mg/SBA-15-IWI cat
	DBD + cat ¹²¹	80	—	40 ^a	—	CoCe or CoLA cat
N₂ + H₂O						
Reduction and oxidation	DBD jet + H ₂ O droplets ⁹²	7854	3010	0.2	3.1	In liquid
	GA + above H ₂ O ⁶⁹	2601	1579	0.6	6.1	In liquid
	Spark jet + above water ⁹³	52	187	—	0.2	In liquid
	Spark jet + H ₂ O vapour ¹⁰³	771	73	0.2	2.3	In gas phase
N₂ + C_xH_yO_z						
Reduction and oxidation	Packed bed-DBD in N ₂ + CH ₄ ⁶⁵	2.7	—	5210	—	Borosilicate glass beds
	N ₂ jet above H ₂ O + EtOH ¹¹³	352	9534	52	5.3	In liquid 20 vol% aqueous EtOH solution
N₂ + O₂(air) + H₂O						
Oxidation and reduction	Plasma electrolytic system ¹³⁷	14.1	8.6	3	—	0.1 M PBS with 500 ppm NO ₂ ⁻
	Hybrid plasma-electrocatalytic system ¹³⁸	15.5	13.7	23.2	0.3	In liquid, Cu nanowires cat
	Hybrid plasma-electrocatalytic system ¹³⁹	—	117	3	69	In liquid, LaFeO ₃ cat., 0.1 M KOH el
	Hybrid plasma-electrocatalytic system ¹⁴⁰	40.5	40.2	39.6	5.9	In liquid, Co ₃ O ₄ nanoparticles cat., 0.11 M NO _x ⁻ + 1 M NaOH el
	Hybrid plasma-electrocatalytic system ¹⁴¹	3.1	2.4	3	1	In liquid Co Sas/N-C cat. 0.1 M KOH el
	—	—	—	—	—	—

^a Production rates reported in mg per hour per g of a catalyst; “In liquid” or “in gas” highlights where the products were observed. Abbreviations “cat.” and “el.” stand for catalyst and electrolyte, respectively

Unfortunately, although N₂ + H₂O plasma systems are characterized by a rich environment with a variety of reactive species, namely additional OH and H₂O₂, these species also have negative effects on NH₃ or NH₄⁺ generation from a physical and chemical point of view. First of all, the presence of water in the plasma zone initiates the quenching of vibrationally excited N₂(X, v) and electronically excited N₂(E).^{78,99,110} This decreases the N₂ activation efficiency. Secondly, at non-thermal conditions, OH is “wasted” on H₂O₂ generation instead of contributing to NH₃ production, while at thermal conditions, OH radicals can trigger reverse reactions ((R3.49)–(R3.51), Table 5), which negatively affects NH and NH₂ generation.⁹⁶ Furthermore, even assuming the complete two-step dissociation of H₂O into H + H + O ((R3.13)–(R3.15) and (R3.17)) from which both H react to form NH_x, the required O–H bond dissociation energy in H₂O is 4.81 eV (464 kJ mol⁻¹), whereas in H₂ it is 4.52 eV

(436 kJ mol⁻¹). This means that to produce the same amount of NH₃, more energy is inherently required when using H₂O instead of H₂. This is clearly seen when looking at the performance of N₂ + H₂O plasma systems with respect to their N₂ + H₂ counterparts presented in Table 6, where the EC is two orders of magnitude higher, and the PR is two orders of magnitude lower for N₂ + H₂O systems.

Interestingly, N₂ + H₂O reduction with H₂O vapor in the presence of a catalyst in a DBD plasma can reduce the contribution of the oxidation pathway and increase the contribution of the reduction pathway.¹⁴³ However, the practical importance of these systems for N₂ reduction is low due to the high EC and low PR.¹²⁸

4.2.3 Nitrogen reduction in N₂ + C_xH_yO_z mixtures. Alternative hydrogen sources have also been explored for NH₃ synthesis. Approximately 50% of the costs in NH₃ production at



HB plants are attributed to H₂ production from methane (CH₄) steam reforming. Direct conversion of CH₄ without steam reforming could have significant economic benefits. Consequently, direct plasma-based conversion of N₂ + CH₄ appears to be an appealing alternative for NH₃ synthesis, as well as for H₂ and olefins production. Bioethanol (bio-EtOH) is another interesting candidate as a hydrogen carrier in the form of C–H and O–H radicals.^{91,144} It is commonly made from agricultural crops such as corn, sugarcane, wheat, or switchgrass, as well as from organic waste materials, food waste, or forestry residues. However, neither CH₄ nor EtOH aligns with the initial concept of green NF because they contain carbon contradicting with the decarbonization goals of the EU. An interesting pathway to reduce C-footprint of NF is H-source from plastic waste which is currently under its primary development. Nevertheless, the NH₃ formation chemistry in N₂ + CH₄ or EtOH mixtures has a scientific interest because value-added side products can also be formed (H₂, C_xH_y), expanding the plasma technology applications.¹⁴⁵ Thus, NF with alternative H sources will be briefly introduced here.

NH₃ formation in hydrocarbon-containing gas mixtures or plasma/liquid systems is poorly investigated but has recently received considerable scientific attention. The major problem lies in the low process selectivity towards NH₃ due to the complexity of plasma-initiated reactions with the involvement of numerous highly reactive species forming various side products of low importance for NF.¹⁴⁶

Evidently, the reaction set expands in the presence of CH₄ as shown in Fig. 3c and Table 5, and the plasma-induced chemistry of CH₄ activation, (R3.52) and (R3.53), can be strongly affected by a variety of parameters: pressure, reactor geometry, and the type of plasma. In plasmas of high *E/n* value, like a DBD, CH₄ activation mainly occurs *via* electron impact reactions and interaction with electronically excited heavy particles. In “warm” plasmas of medium-range *E/n*, such as a GA, thermal dissociation of CH₄ is expected to be predominant (CH₃ →^{heat} products). However, under high-temperature conditions, NH₃ formation is highly unlikely, and thus, it is expected to occur only in the lower-temperature plasma compartments, *e.g.*, in the afterglow zone.

Another significant feature of N₂ + CH₄ plasmas is the formation of hydrogen cyanide (HCN), *e.g.* (R3.55), (R3.59) and (R3.60).^{147,148} HCN is extremely toxic and poses a significant risk of rapid harm. Its concentration in N₂ + CH₄ plasmas can be comparable to or even higher than the concentration of NH₃.¹⁴⁹ Consequently, stringent safety measures are essential when dealing with such an NF method. Nonetheless, HCN is also a value-added chemical, and its synthesis is a topic of many studies.¹⁵⁰

Alcohols, including EtOH can also be potentially utilized for NH₃ production (see Fig. 3d and Table 5 for details), being introduced into the plasma zone through various means such as vapor, steam, or liquid interface. In plasma, it undergoes activation *via* electron impact and N₂ excited states (R3.61)–(R3.65) and consequent product recombination, yielding a range of reactive species, including CH₃, H, OH, H₂, CH₃CHOH, *etc.*, ultimately resulting in the production of H₂, CO, CO₂, NH₃, C,

and other products.^{151–153} The selectivity towards particular species is the subject of numerous studies and is significantly influenced by experimental conditions (pressure, gas mixture composition), plasma type (non-thermal, warm, thermal), and the presence of different phases (gas, liquid, solid (catalyst)). Some of the possible routes of NH₃ formation specific to ethanol are described below. Given the low evaporation temperature of EtOH (351 K at atmospheric pressure), the gas phase is always enriched by gaseous EtOH. Considering this, thermal activation mechanisms must also be considered (CH₃CH₂OH →^{heat} products).¹⁵⁴ Overall, exposing plasma above liquid EtOH-water mixtures can enhance the production rate of NH₄⁺. This is generally attributed to the increased lability of the H atom and OH radical at the central CH₂ group (R3.61)–(R3.64).¹¹³

To summarize, plasma-based NH₃ synthesis in N₂ + C_xH_yO_z feedstock systems is feasible, but the process selectivity strongly depends on the type of plasma. Under non-thermal and strongly non-equilibrium conditions, where activation primarily occurs through non-elastic collisions (as in DBDs), NH₃ can be generated in significant quantities in the gas phase for the N₂ + CH₄ system and promoted in the liquid phase (comparing N₂ + H₂O and N₂ + H₂O + EtOH), as illustrated in Table 6. However, under elevated temperature conditions (such as GA and MW), the selectivity shifts towards the generation of H₂, olefins, and C (soot). This shift is likely due to reverse processes with highly temperature-dependent reaction rate constants, *e.g.*, (R3.69) and (R3.70), and NH₃ thermal decomposition.

4.2.4 Nitrogen reduction in N₂ + O₂ (air) + H₂O mixtures.

From an application standpoint, the most desirable scenario for nitrogen reduction involves utilizing air as a source of nitrogen since it is readily available in abundance. However, transitioning from pure N₂ to an air plasma leads to a dramatic decrease in NH₃ production.⁹¹ Moreover, the selectivity of NF shifts towards N₂ oxidation, as detailed in Section 3.1. In fact, in nearly all works found in literature, the only products of the N₂ + O₂(air) + H₂O reactive plasma systems are NO_x and HNO_x.¹⁰⁸ Nonetheless, NH₃ formation may occur even in N₂ + O₂ (air) + H₂O systems, with and without a catalyst. However, the two examples to date focus either on DBD plasma catalysis with H₂O vapor or pulsed spark plasma with a very low duty cycle (*i.e.*, inherently low throughput).^{103,155} Thus, such a direct one-step plasma N₂ reduction approach demonstrates poor performance in terms of both PR and EC, rendering it impractical. Still, some of these works reveal an important point to consider: if the plasma feed gas contains large amounts of H₂O vapor, the formed NH₃ will react with the formed HNO₂, yielding NH₄NO₂, which is unstable at ambient conditions and decomposes back to N₂, and H₂O.¹⁰³ Thus, a high humidity content can be detrimental to plasma NF *via* oxidation into NO_x.

To conclude this section, NH₃ formation chemistry across various feedstocks, including N₂ + H₂, N₂ + H₂O, N₂ + C_xH_yO_z, and N₂ + O₂(air) + H₂O is also examined. The proposed reaction schemes offer simplified representations, enabling an understanding of fundamental mechanisms. However, plasma-induced chemistry poses prediction challenges, involving hundreds to thousands of chemical reactions. Nonetheless,



analysis suggests that process selectivity is influenced by feedstock activation; the more energy demanding the activation, the higher the EC and the lower the PR. Furthermore, the presence of numerous active species complicates the chemistry, presenting both advantages and disadvantages. This includes the potential for enhanced initial reduction pathways (to form NH_3), as well as the risk of reverse processes, especially pronounced at elevated temperatures.

5 From plasma nitrogen fixation to NH_4NO_3 fertilizer

In general, NF processes, including plasma-based approaches, do not directly produce ready-to-use fertilizers but instead generate precursors, or “building blocks”, such as NH_3 (see Section 3.2) or $(\text{H})\text{NO}_x$ (see Section 3.1). These core materials serve as essential components in the subsequent synthesis of nitrogen-rich fertilizers that can effectively enhance soil nitrogen content for plant growth. However, due to the wide variety of plant nutrient requirements, this discussion focuses exclusively on nitrogen-based fertilizers. Fertilizers designed to supply other essential elements, such as phosphorus (P) or potassium (K), fall outside the scope of this review.

This subsection aims to provide a broad perspective on the development of plasma-based fertilizer technologies, focusing on general scientific and technological principles rather than delving into economic feasibility or industrial-scale implementation. By narrowing the scope, this part serves as a foundational introduction to the challenges and opportunities in plasma-based fertilizer production, catering specifically to readers who are new to the field. It offers a conceptual framework to understand how plasma technologies can contribute to advancing sustainable agriculture while leaving more detailed discussions on economics and industrialization to specialized studies. For newcomers, this serves as an entry point into the intricate problematics of plasma-

based fertilizer synthesis, setting the stage for more in-depth exploration in future studies.

5.1 Targeted fertilizer

The wide variety of synthetic fertilizers employed nowadays ranges from ammonium phosphates or sulphates (where N is present in the cationic form) to nitrates (with N in the anionic form, or both in cationic and anionic form, *i.e.*, NH_4NO_3) and even organic molecules such as urea (Fig. 4). As already discussed in Section 1, urea, although possessing the highest N content, compromises the decarbonization strategy due to the unavoidable CO_2 emissions when being used.¹⁵⁶ Of all other fertilizers, ammonium nitrate has the highest N content and is carbon-free. Thus, it is chosen as the target compound in this work to illustrate a plasma-based approach in fertilizer production.

In Sections 3.1 and 3.2, the plasma-driven chemical processes involved in N_2 oxidation and reduction in various reactive systems, with and without O_2 , H_2O , *etc.*, were detailed. However, neither of the two processes (oxidation and reduction) individually leads to the desired fertilizer— NH_4NO_3 .

5.2 Possible pathways of NH_4NO_3 synthesis involving electrified plasma technology

Here, we will focus on the ways of obtaining NH_4NO_3 , which involve plasma NF to substitute, or at least reduce the contribution of the industry-dominating HB. So far, the majority of the researchers have focused on improving NO_x and NH_3 synthesis separately to achieve the best process performance in terms of lowest EC and highest PR. Often, these two parameters are counter-effective: the lowest EC is accompanied by low PR and *vice versa*, with a proper balance yet to be found. This bottleneck must be solved to achieve a wide application of this technology.

Synthetic Nitrogen Fertilizer Chain

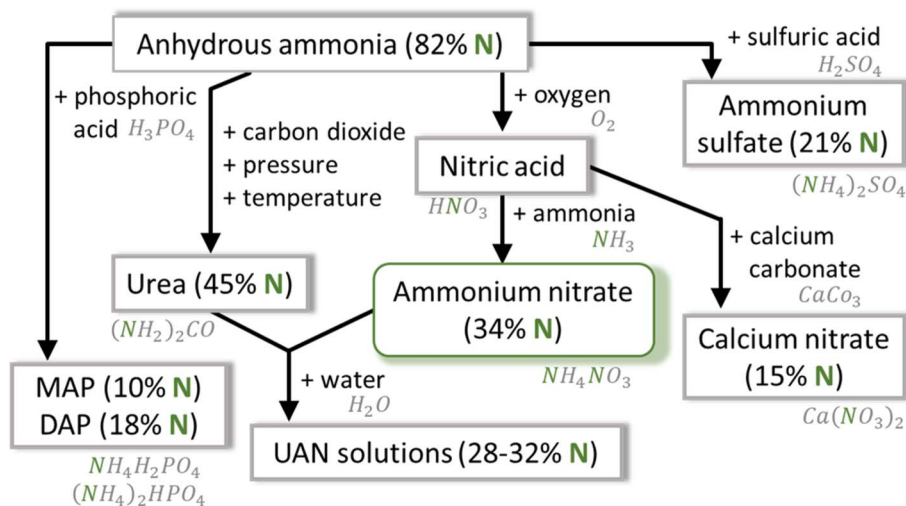


Fig. 4 Commonly used fertilizers, their production pathways and conditions, and nitrogen content.



Let us first consider several pathways of NH_4NO_3 production involving plasma NF. Considering the demands of the agricultural sector and the capacity of plasma technology to facilitate the synthesis of both HNO_3 and NH_3 , the in-place production of NH_4NO_3 can be accomplished if “green” energy supplies are available directly on the farm field. For the NH_4NO_3 production, the process can be subdivided into two steps, namely (i) HNO_3 and (ii) NH_3 generation. Techno-economic analysis of the approach has been carried out recently, showing importance of energy costs of NF in the overall value chain of fertilizers synthesis.¹⁵⁷

Naturally, the most direct alternative to HB is the direct synthesis of NH_3 and its subsequent partial oxidation to HNO_3 , followed by combining NH_3 and HNO_3 into NH_4NO_3 as the ultimate output product (Fig. 5a). As discussed in Section 3, the route using C-containing H sources is not feasible in the long term within the new decarbonization policies. Therefore, the reduction agents are limited to H_2 and H_2O . Furthermore, the choice of plasma type is also restricted to highly non-equilibrium, non-thermal plasmas – e.g., DBD. However, DBD plasmas, even in combination with catalysts, typically have a low throughput and high EC. The EC usually belongs in the range of 10–100 MJ mol^{-1} (Table 6), while the estimated requirement for plasma NF to be competitive with HB is 1–1.5 MJ mol^{-1} .^{17,18,128} Moreover, since NH_3 cannot be used as a fertilizer as-is, it would need to be further oxidized into HNO_3 . Although distillation of N_2 from the air is not strictly needed because NH_3 can also be produced by plasma from the air with,

e.g., H_2O as the H source, the EC and PR values remain below the required levels. Thus, such a route is not the most feasible.

An alternative route involves the production of NH_3 via the aforementioned plasma N_2 reduction and (separately) production of NO_x/HNO_3 , which can later be combined with NH_3 to produce NH_4NO_3 (Fig. 5b). Here, the production of NO_x can be done from air in direct plasma N_2 oxidation. This oxidative plasma NF can be performed in a variety of ways, which are described in detail in Section 3.1 and can be implemented in non-equilibrium plasmas such as GA, DC arc, and MW. However, it should be emphasized that plasma N_2 oxidation of dry air in more thermal plasmas has the lowest EC and the highest PR of all reported routes of plasma-based NF ($\sim 2.3 \text{ MJ mol}^{-1}$, $\sim 3.2 \text{ g h}^{-1}$, Table 6).^{50,131} Moreover, the data presented in Table 6 for $\text{N}_2 + \text{O}_2$ systems is for systems with air ($\text{N}_2 : \text{O}_2$ ratio 4 : 1), whereas with oxygen-enriched mixtures, the values of EC and PR can be further improved,^{42,50} although at the EC of oxygen production. The plasma-formed NO_x can be further dissolved in H_2O , which, in the presence of unreacted O_2 from the air, results ultimately in an HNO_3 solution. Here, two other points must be also addressed. Although technically, HNO_3 can be formed directly in the liquid phase when creating direct contact between liquid H_2O and plasma, part of the energy is inevitably lost to the evaporation of H_2O and the quenching of excited N_2 , which has a negative impact on the EC.^{101,158} Thus, although this route has a higher electrification potential due to the strong feasibility of using plasma for N_2 oxidation than the

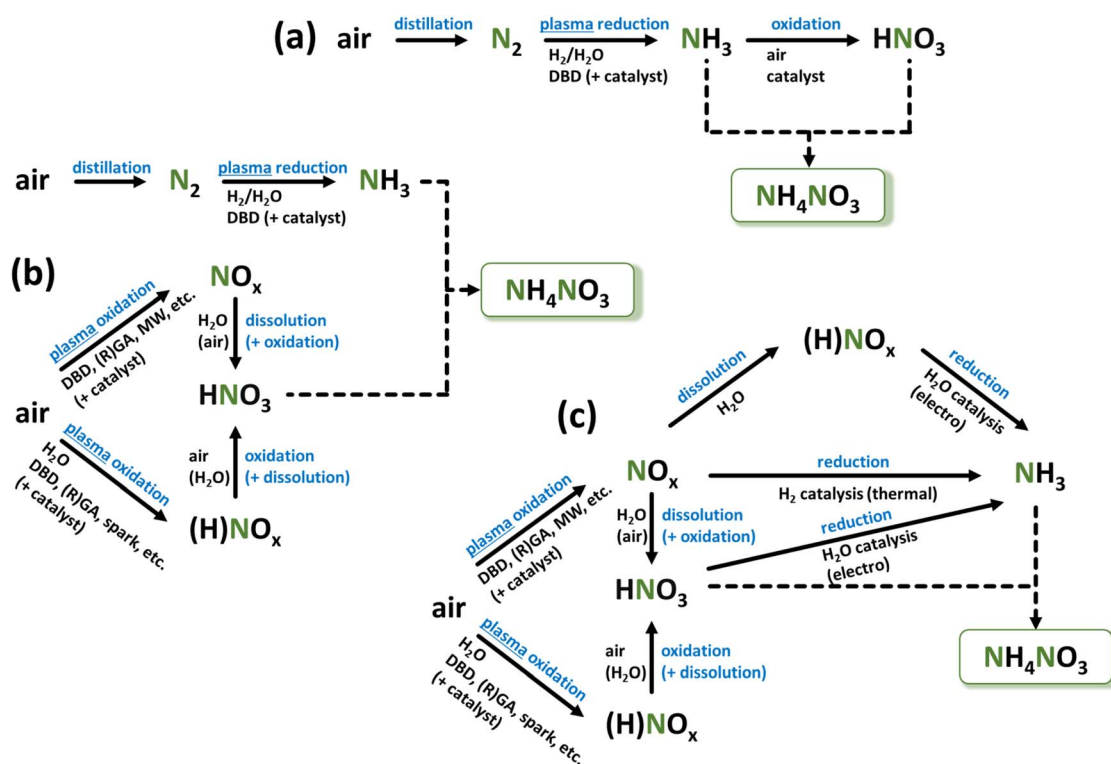


Fig. 5 Pathways of NH_4NO_3 production via plasma-based NF: (a) plasma production of NH_3 coupled with its subsequent (partial) oxidation to HNO_3 ; (b) plasma production of $(\text{H})\text{NO}_x$ coupled with plasma-based production of NH_3 ; (c) plasma production of $(\text{H})\text{NO}_x$ coupled with its subsequent (partial) reduction to NH_3 .



one described in Fig. 5a, direct plasma-based N_2 reduction is still a limiting factor.

A plasma-based pathway to NH_4NO_3 , which does not involve plasma N_2 reduction, is shown in Fig. 5c. Here, the only substrate is air, without the need for distillation of N_2 . Air is used to produce NO_x using warm (or thermal) plasmas, which have significantly higher throughput and lower EC than non-thermal (e.g., DBD) plasmas. After this, the NO_x needs to be reduced to NH_3 . One of the ways proposed in the literature is thermocatalytic over-reduction of NO_x over lean NO_x trap catalysts commonly used in the automotive industry in the presence of H_2 .^{24,159} Such a process does not require a separation step because the catalyst acts as a NO_x adsorber itself. However, it does require producing H_2 first, either from CH_4 (again, compromising decarbonization) or from the electrolysis of H_2O , and a heat source to activate the thermocatalytic reaction.²⁴ Although a very low EC was reported for such a combined plasma oxidation/thermocatalytic reduction process, this EC is accompanied by a low PR (2.1 MJ mol⁻¹, 17.3 mg h⁻¹; Table 6), and the activity range may be limited to low concentrations of the initially plasma-produced NO_x .

Here, it is acknowledged that if the goal is fertilizers without producing NH_4NO_3 specifically, the plasma N_2 oxidation step is nearly sufficient to produce nitrates, which already possess fertilizer properties. However, to turn them from acidic solutions into applicable fertilizers, neutralization is still required, e.g., with caustic soda or other chemicals. This, together with the increased N content of NH_4NO_3 , makes it a more desirable product.

5.3 From plasma oxidation to electrochemical reduction

Electrochemical reduction of the plasma-produced NO_x is another alternative way to NH_3 .^{38,118,160} The electrochemical reduction is normally carried out in a two-compartment H-type cell, where an ion-exchange membrane separates both compartments.¹⁶¹ The cell is typically equipped with a three-electrode configuration: a working electrode, where the reduction occurs; a counter electrode, which provides the current needed for the reaction; and a reference electrode, which monitors the electrode potential. A catalyst, often in the form of nanoparticles or single atoms, is immobilized on the surface of the working electrode or dispersed within the electrolyte solution. It serves to lower the activation energy barrier for the reduction reactions, thereby increasing the reaction rate and improving selectivity. A typical performance of hybrid plasma-electrocatalytic systems is presented in Table 6. The EC in such systems is the sum of N_2 oxidation and N_2 reduction steps, performed in series *via* plasma and electrochemical approaches, respectively. The electrocatalytic NO_x into NH_3 process illustrates the best state-of-the-art EC values, ranging between 3–15 MJ per mol NH_3 , and reasonable PRs for laboratory scale systems.

Electrochemical reduction reactions are well-known and do not specifically involve plasma chemistry. Therefore, these are not addressed here. However, it should be noted that although HNO_3 in an aqueous solution can be reduced to NH_3 , the

reduction of HNO_2 occurs faster.¹³⁷ The ratio of HNO_2/HNO_3 in the water after passing the plasma exhaust gasses through it depends on the initial ratio of NO/NO_2 produced during plasma N_2 oxidation and can be controlled by varying plasma parameters. Thus, several concepts can be proposed. In one, the plasma-produced NO_x mixture is dominated by NO_2 , which, accompanied by continuous recirculation through a water solution with O_2 from the air, forms NO_3^- in the solution. Without any separation steps, this NO_3^- is further partially reduced electrochemically to NH_4^+ , in the same solution. Such one-pot synthesis is the simplest on-site fertilizer production concept, utilizing only renewable energy (plasma and electrochemical cells can be powered by, e.g., solar panels) and ubiquitous materials such as air and water. On the other hand, if the NO_x^- containing plasma output stream contains lower fractions of NO_2 , the liquid phase can be shifted to mostly NO_2^- , which requires less energy to be reduced to NH_4^+ . To avoid dividing the NO_x stream to produce HNO_3 in one of them and HNO_2 -to- NH_3 in another, one can envision that NO_2^- is first partially reduced to NH_4^+ , and then the remaining NO_2^- in the solution is oxidized to NO_3^- by recirculating air through it. Of course, at this stage, the comparison between the two concepts is purely speculative: the exact values of EC and PR of the whole process need to be assessed in dedicated future works.

6 Conclusion and Outlook

This tutorial discusses the fundamentals of plasma-based nitrogen fixation for fertilizers as a sustainable alternative to conventional methods. Through this work, the reader can acquire knowledge about elementary processes in plasmas (Section 2), the role of vibrational excitation (Section 2), the chemistry of nitrogen oxidation (Section 3.1) and nitrogen reduction (Section 3.2) in various feedstocks, and how these processes can be integrated to produce the final product – a fertilizer (Section 4). Finally, we provide key conclusions, perspectives, and challenges.

6.1 Plasma technology is a sustainable alternative

The nitrogen fertilizer industry aims to meet the demands of modern agriculture while being independent of fossil fuels due to related economic and ecological problems. Given these premises, plasma technology presents an attractive alternative for converting N_2 into nitrogen-based fertilizers in a manner that aligns with current sustainability goals. However, implementing the plasma-based approach necessitates a reconsideration of the existing soil fertilization paradigm, specifically a pivotal shift from large-scale centralized production to on-site direct synthesis. This shift is highly challenging, but the potential collective benefits could be immense. In this approach, valuable nitrogen species (NO_3^- and/or NH_4^+) do not require separation or recycling, thereby reducing associated energy costs. Instead, they can be synthesized directly from inexpensive feedstock (air) using plasma oxidation or reduction processes, as described in previous sections, and applied shortly thereafter.



6.2 Which type of plasma should be used?

So far, warm plasmas show the best EC and NO_x yield. This is often attributed to a significant vibration excitation of N₂. However, the contribution of vibrational states to NO production in such plasmas is still unclear and, based on modeling, often considered to be comparable with thermal N₂ dissociation. Thus, an experimental study investigating the N₂ vibrational excitation degree in atmospheric pressure air plasmas is of high interest and can provide insights into non-thermal plasma chemistry. The enhancement of vibrational excitation can be achieved by tailoring the applied voltage waveform, *e.g.*, combining ns-pulses with DC bias and ns-pulses with RF or MW, leading to a unique unrivaled chemistry.

6.3 Challenges in plasma-based reduction

In contrast to HB's industrial scale N₂ processing to NH₃, the plasma-initiated reduction route is less developed and studied. The underlying chemistry of reduction is based on the reaction of very short-lived intermediates, such as OH, NH, and N radicals, particles difficult to detect. The future direction of research should tackle the complex chemical kinetics behind N₂ reduction to reveal the full potential of this route in NF.

6.4 Complexities in liquid phase processes

Although water is recognized as a green source of hydrogen, the challenges of enhancing plasma nitrogen fixation become even greater when liquids are present in the process environment. A combined oxidation and reduction process can take place both in the gas and liquid phases, complicating pathway elucidation. Insight into mechanisms is lacking, and there is no consensus on the role of H₂O. In addition, the transport of plasma species into the liquid is poorly understood.

6.5 Plasma-catalytic processes

As a possibility in both reduction and oxidation routes in NF, the plasma-catalytic approach is an important step toward industrial applications. It is well known that catalysts cannot directly facilitate N₂ dissociation under milder conditions due to the inherent stability of the nitrogen triple bond. However, plasma-based nitrogen oxidation can still be aided by promoting O₂ dissociation *via* heterogeneous catalysts. Atomic O-enriched medium can positively contribute to NO_x formation by boosting the Zeldovich mechanism that can take place on the surface of a catalyst. Despite foreseen benefits in plasma-catalytic processes, the best-performing catalysts have to be yet defined and tested in industry-relevant conditions.

6.6 Perspective and challenges

Based on the current state-of-the-art, it has been indicated that the most attractive route to the on-site, small-scale, decentralized production of NH₄NO₃ for fertilizer applications is initial plasma oxidation directly from air, followed by accumulating the products in aqueous solutions (in the form of HNO_x), and their subsequent electrochemical or catalytical reduction. Moreover, the oxidation and reduction steps can be time-

differentiated to accommodate the difference in the production rate in each step. Another important feature of such a combined plasma oxidation/electrocatalytic reduction approach is that the resulting product, NH₄NO₃, is already in solution and ready to be applied on farming sites. In contrast, the centralized HB production implies the distribution of NH₄NO₃, which is done in solid form as the most concentrated method to reduce transport costs.¹⁶² However, this, in turn, means the necessity of storage facilities, which, in combination with the explosivity of NH₄NO₃, sometimes leads to hugely destructive accidents.¹⁶³

As a final remark, several other approaches to fertilizer production *via* plasma-based NF will be briefly mentioned. Many natural fertilizers (*e.g.*, cattle and pig waste) can be effectively recycled. The manure contains N (2–8.1 g kg⁻¹)¹⁶⁴ with an NH₄⁺ content of about 70%, which is released over time due to the high pH in the animal waste. This volatilization is estimated in the range of tens of kg per hectare of fertilized soil.¹⁶⁵ Industrial-level attempts, including recent research in N₂ applied, are made to reduce such NH₃ losses by producing NO_x *via* plasma N₂ oxidation from the air and further applying this NO_x to create NH₄NO₃ in the waste slurry.^{166,167}

Overall, plasma technology enables a large variety of approaches, directions, and possibilities in NF for fertilizers, making them compatible with the electrification and decarbonization policies. The NH₄NO₃ synthesis routes discussed in this work (see Section 4 for details) have a solid foundation and should be the focus of future investigations. Beyond fundamental scientific information, a detailed techno-economic analysis of the proposed approaches can reveal the potential capital costs of the product.^{17,18,168–171}

Data availability

No experimental data were used in the preparation of this manuscript.

Author contributions

M. Gromov: conceptualization, data curation, investigation, formal analysis, visualization, writing – original draft, writing – review & editing. Y. Gorbanev: conceptualization, data curation, visualization, writing – original draft, writing – review & editing. E. Vervloessem: investigation, formal analysis. R. Morent: funding acquisition, writing – review & editing. R. Snyders: funding acquisition, writing – review & editing. N. De Geyter: funding acquisition, writing – review & editing. A. Bogaerts: funding acquisition, writing – review & editing. A. Nikiforov: conceptualization, data curation, visualization, writing – original draft, writing – review & editing.

Conflicts of interest

There are no conflicts to declare.



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